

 **Savard**

18 and '87

Aug 2007

	U	1	inventor	Document#	Issue	P	Title	Current	Current	XA	Review	S	C	P	2	3	4	5	6	Image	Doc.	P
1	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Rinerson, Dar	US 2004015	2004:02		Conductive memory device with barrier elect	257/295				<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004015		
2	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Mei, Hai	US 2003023	2003:01		Variable capacitance measuring device comp	73/718				<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003023		
3	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Wang, You et	US 2002007	2002:01		Electrostatic chuck bonded to base with a be	361/234				<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2002007		
4	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	SHAMOUILA	US 2002003	2002:01		ELECTROSTATIC CHUCK HAVING COMPOS	361/234	279/128			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2002003		
5	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Visco, Steven	US 6682842	2004:09		Composite electrode/electrolyte structure	429/33	429/41			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6682842		
6	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Wang, You et	US 6538872	2003:01		Electrostatic chuck having heater and metho	361/234	361/103			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6538872		
7	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Wang, You et	US 6480146	2002:01		Electrostatic chuck bonded to base with a bo	361/234	361/103			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6480146		
8	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Shamoullian	US 6462928	2002:01		Electrostatic chuck having improved electric	361/234				<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6462928		
9	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Kholodenko,	US 6310755	2001:01		Electrostatic chuck having gas cavity and me	361/234	361/115			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6310755		
10	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Horiuchi, Ken	US 6184621	2001:02		Plasma display and method for manufacturin	313/586	313/581			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6184621		